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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kazuhiro OTSU et al.

Serial No. [NEW]

Filed February 7, 2002

SEPARATING MACHINE FOR THINNED SEMICONDUCTOR SUBSTRATE AND

SEPARATION METHOD

Attn: Application Branch

Attorney Docket No. 2002-0208A

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE

FEE FOR THIS PAPER TO DEPOSIT

ACCOUNT NO. 23-0975.

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents, Washington, DC 20231

Sir:

In the interest of compact prosecution and to reduce PTO filing fees, please amend the present application as follows:

IN THE CLAIMS:

Please rewrite claim 4 as follows:

4. (Amended) A separating machine for a thinned semiconductor substrate according to claim 2, wherein the system for making a starting point for the separation is a system of pressing with a knife edge.

Please add the following new claim:

9. (New) A separating machine for a thinned semiconductor substrate according to claim 3, wherein the system for making a starting point for the separation is a system of pressing with a knife edge.